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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6548**  
Sunji ICHIKAWA : Docket No. 2004-0095A  
Serial No. 10/763,227 : Group Art Unit 2822  
Filed January 26, 2004 : Examiner Roy Karl Potter

LEAD FRAME, MANUFACTURING METHOD  
OF THE SAME, AND SEMICONDUCTOR  
DEVICE USING THE SAME

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

In response to the restriction requirement on page 2 of the Office Action dated April 25, 2005, the Applicant hereby elects **Invention II**, which is drawn to a semiconductor device. Claims 3-4 read on the elected invention.

Having made the required election, a full examination on the merits is respectfully requested.

Respectfully submitted,

Sunji ICHIKAWA

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